

JOIN US FOR CVD 2006

SCIENCE-ENGINEERING-TECHNOLOGY

28-29 MARCH
WASHINGTON, D.C.

WHAT IS CONGRESSIONAL VISITS DAY?

CVD is a two-day annual event in Washington, D.C. that brings together scientists, engineers, researchers, educators, and technology executives to raise visibility and support for science, engineering, and technology. Uniquely multi-sector and multi-disciplinary, CVD is coordinated by a coalition of companies, professional societies and educational institutions and is open to all who support research and development activities. The event consists of a series of briefings, a Congressional reception, and highlighted by meetings with your Congressional delegation.

OBJECTIVE

To underscore the long-term importance of science and technology that supports the Nation's global competitiveness, through meetings with Members of Congress, Congressional staff, key Administration officials and other decisionmakers.



CORE MESSAGES

- Balanced Federal investment in science, engineering, and technology is fundamental to the future of our Nation's prosperity
- Effective competitiveness and innovation policies will sustain U.S. technological leadership and encourage the development of a skilled, creative and competitive workforce.

HOW TO PARTICIPATE

You can register online at:

www.ieeeusa.org/policy/cvd/register.html

or complete the attached registration form and send it to:

Deborah Rudolph, IEEE-USA

Fax: 202-785-0835

E-Mail: d.rudolph@ieee.org

Note: Registration Deadline: 20 March 2006
CVD Website: www.aas.org/policy/cvd